

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	5307	porous adj silicon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/06 13:34
L2	378399	((("257") or ("438"))).CLAS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/06/06 13:35
L3	1838	l1 and l2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/06 13:35

Search: List: Exclude: Quoted:
DBs: ☒ Plurals:
Default opera Highlight all in terms initially

S20 and
((pressure adj
sensor) with
(layer film near4
(porous porosity
bubble cavity void
microporous
nanoporous))

S20 and
((pressure adj
sensor) with
(layer film near4
(porous porosity
bubble cavity void
microporous
nanoporous))